

Phu



Docket No.: 065933-0084

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Kyosuke USUI, et al.

: Customer Number: 20277
:
: Confirmation Number: 3812
:
: Group Art Unit: 2814
:
: Examiner: Dilinh P. Nguyen
:

Application No.: 10/813,629

Filed: March 31, 2004

For: SEMICONDUCTOR MODULE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each reference was cited in a corresponding Japanese office action and its relevance discussed therein. A copy of the Japanese office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 SAB:jwp
Facsimile: 202.756.8087
Date: June 6, 2007

**Please recognize our Customer No. 20277
as our correspondence address.**

INFORMATION DISCLOSURE

CITATION IN AN APPLICATION

ATTY. DOCKET NO.
065933-0084

SERIAL NO.
10/813,629

APPLICANT
Ryosuke USUI, et al.

FILING DATE.
March 31, 2004

GROUP
2814

(PTO-1449)



U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 2002-110721	04-12-2002	HITACHI LTD; HITACHI HOKKAI SEMICONDUCTOR LTD		Japanese (w/English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Japanese Office Action issued in corresponding Japanese Patent Application No. JP 2004-086770, dated March 6, 2007.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.